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U.S. PATENTS

Initials	Patent Number	Issue Date	Name	Class	Sub-class	Filing date

U.S. PATENT PUBLICATIONS

Initials	Publication No.	Pub. Date	Name	Class	Sub-class	Filing Date
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Initials	Document Number	Date	Country	Name	Translation? Yes/No/n/a
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OTHER DOCUMENTS (Title, Author, Date, Pages, Etc., if known)

	Korean Office Action dated 8 September 2008 issued in corresponding Korean Patent Application No. 10-2006-7008189 (5 pages)
	Korean Office Action (English Translation) dated 8 September 2008 issued in corresponding Korean Patent Application No. 10-2006-7008189 (5 pages)

Examiner's Signature:

Date Considered:

Initial if reference was considered, whether or not citation is in conformance with MPEP. Mark through citation if not considered.

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